

Robotics and Artificial Intelligence

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CSAIL



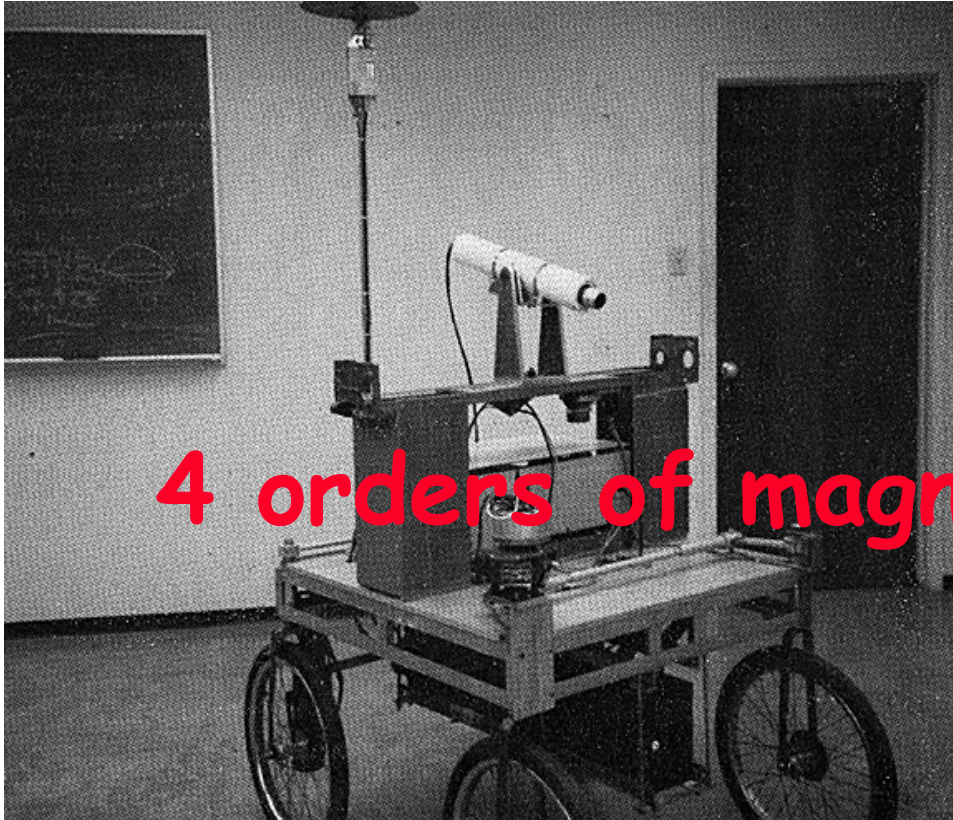
iRobot®

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Stanford AI Lab



1979: 20 meters/6 hours

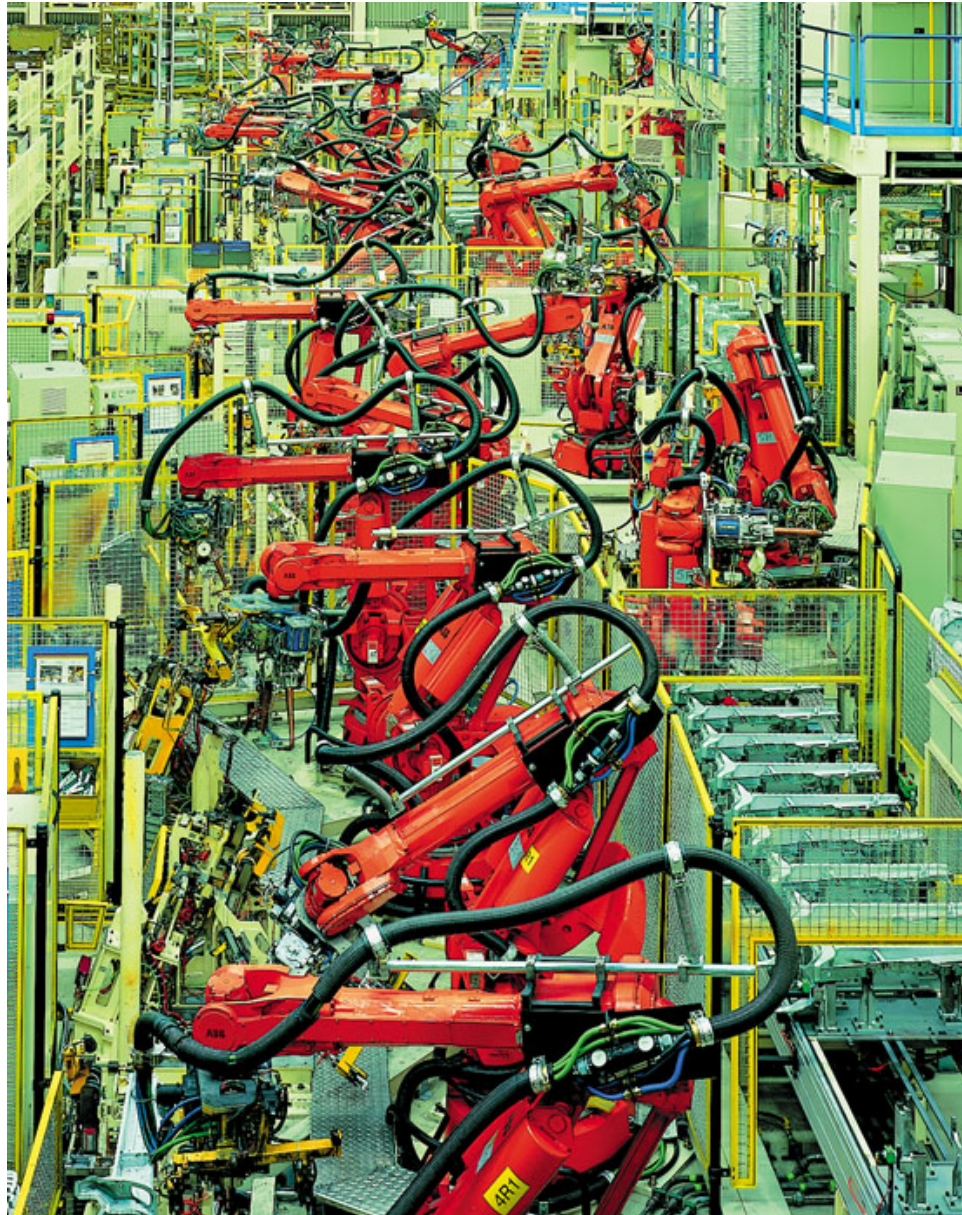


4 orders of magnitude in 26 years

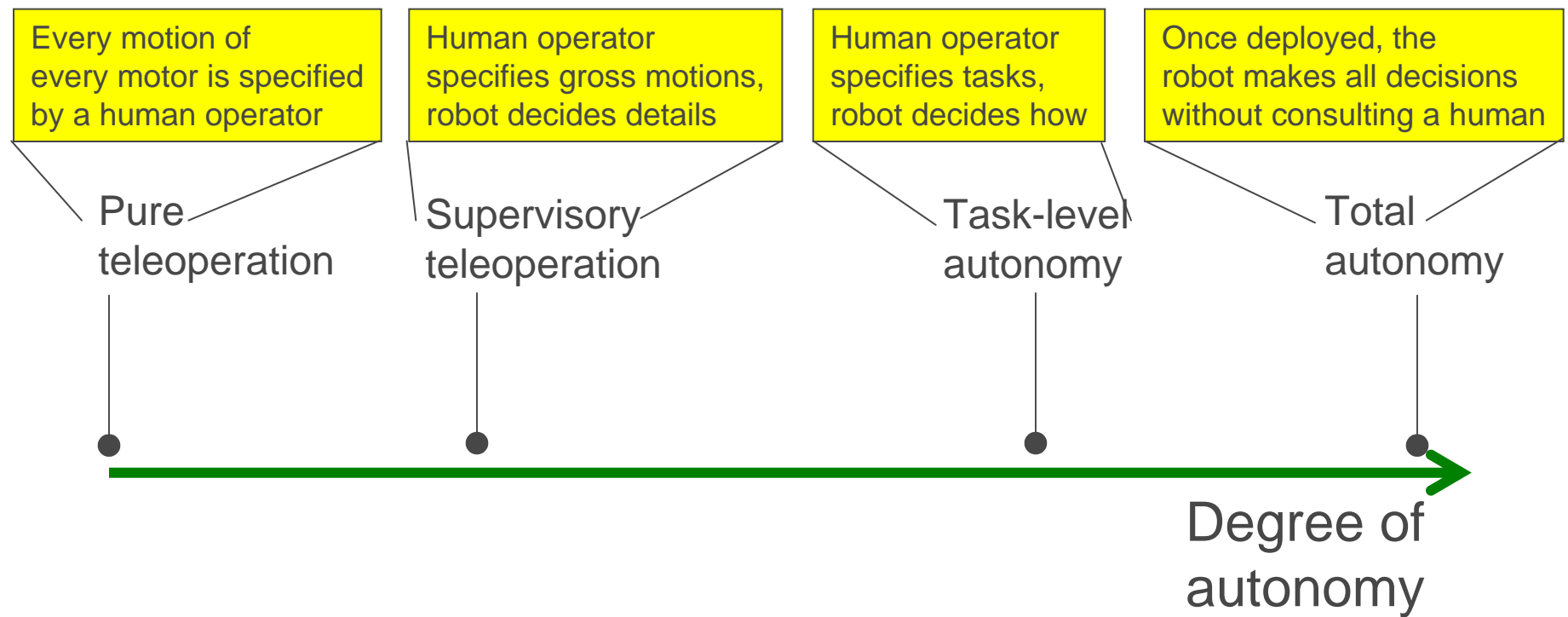
2005: 200 kilometers/6 hours



Our Recent View of Robots



Autonomy For Robots



Autonomy Levels



Pure
teleoperation



Supervisory
teleoperation



Task-level
autonomy

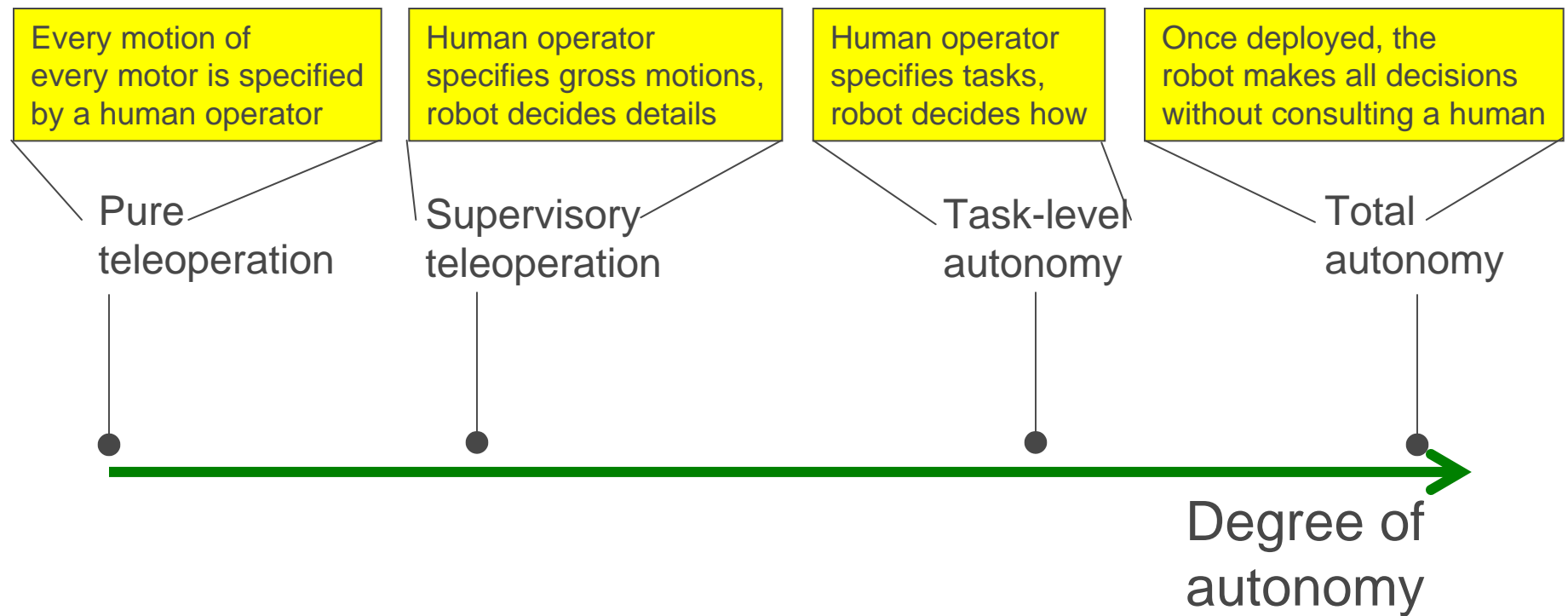


Total
autonomy



Degree of
autonomy

Autonomy For Robots



iRobot Autonomy Levels



Pure
teleoperation



Supervisory
teleoperation



Task-level
autonomy



Total
autonomy



Degree of
autonomy

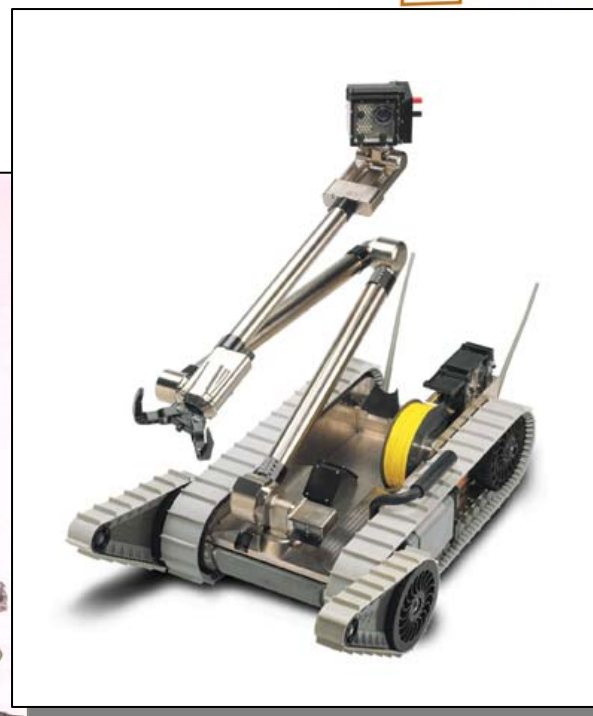


PackBot EOD





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PackBot #129

Killed In Action
April 8, 2004
Iraq



iRobot®





iRobot®

Why Manipulation for Robots?



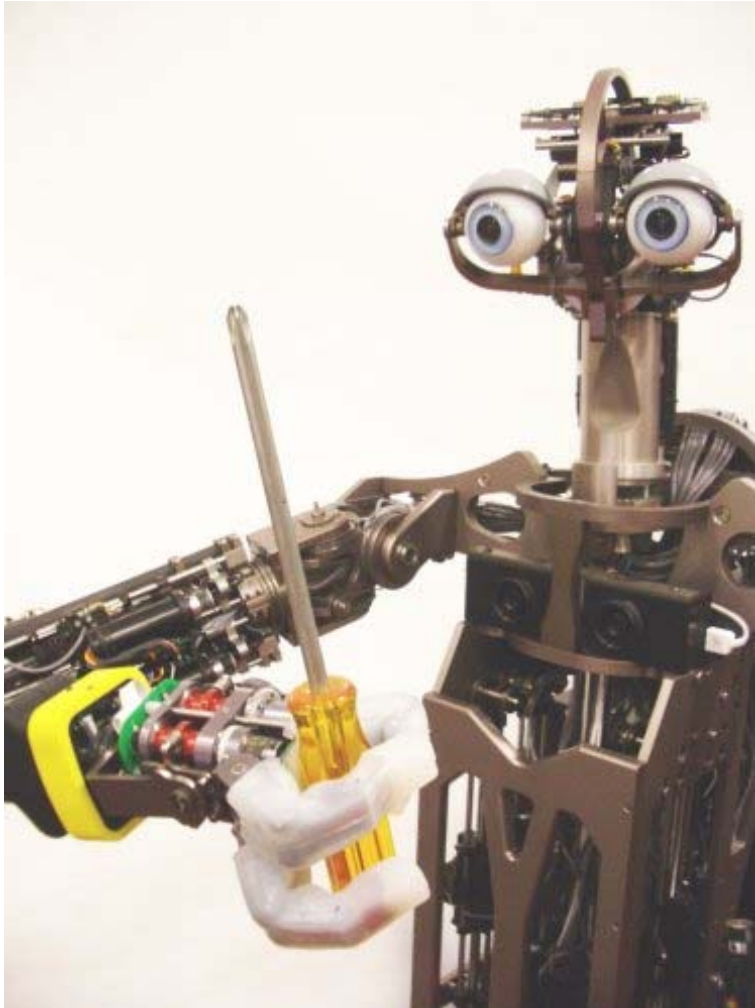
- Teleoperation of manipulation is slow and difficult
 - for EOD missions this is currently acceptable but not optimal
 - for tactical situations it is not acceptable
- Tasks for manipulation in tactical situations
 - opening doors
 - rapidly placing charges
 - poking and lifting
- Tasks for manipulation elsewhere
 - logistics and supply
 - casualty removal

State of Art in Robot Manipulation



- Deployed
 - pre-engineered in carefully controlled environments
 - pure (or marginally supervisory) teleoperation
 - » perhaps after a task-level or fully autonomous traverse
- Touch Sensors
 - mostly rigid
 - mostly require too much pressure
 - mostly measure only normal force

Lab Robots For Grasping



Force only



Force and touch

Pure Force Control

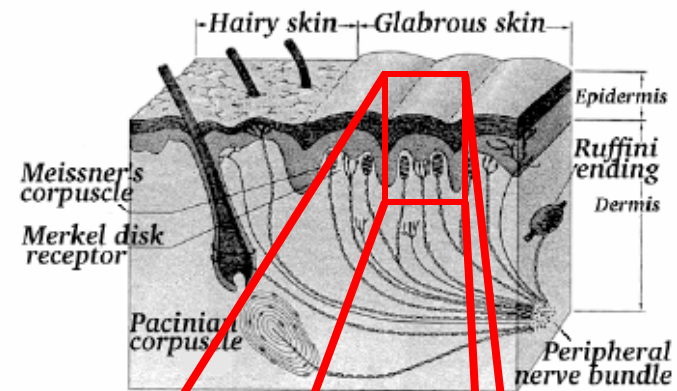


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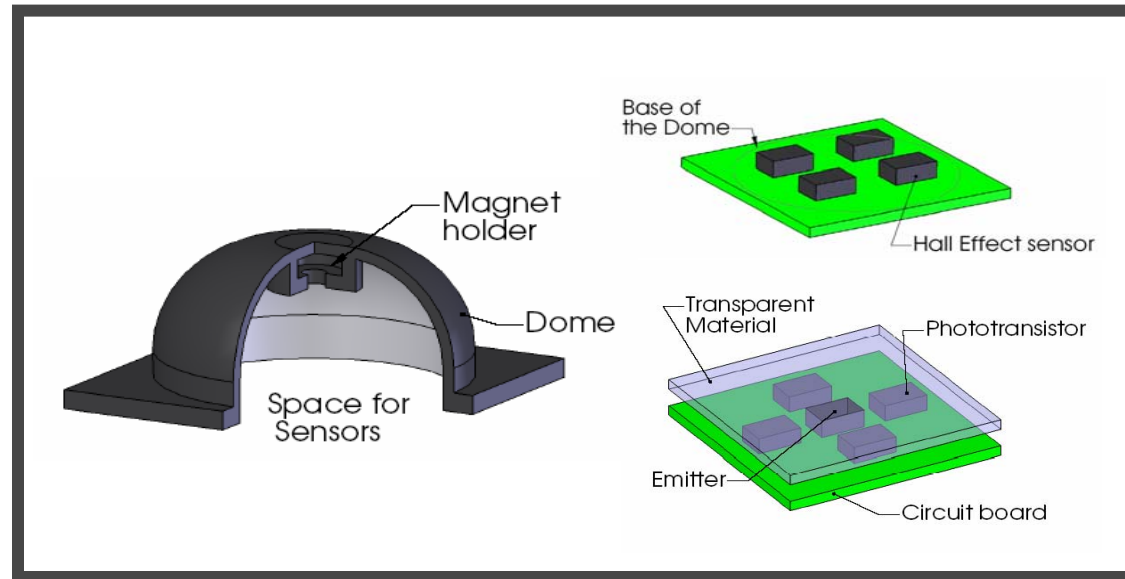
Our Approach to Touch



- Biological inspired sensors.
 - Dome shaped
 - Deformable
- Sensors favor compliance over spatial resolution.
- RIDGES



Approach to Tactile Sensing

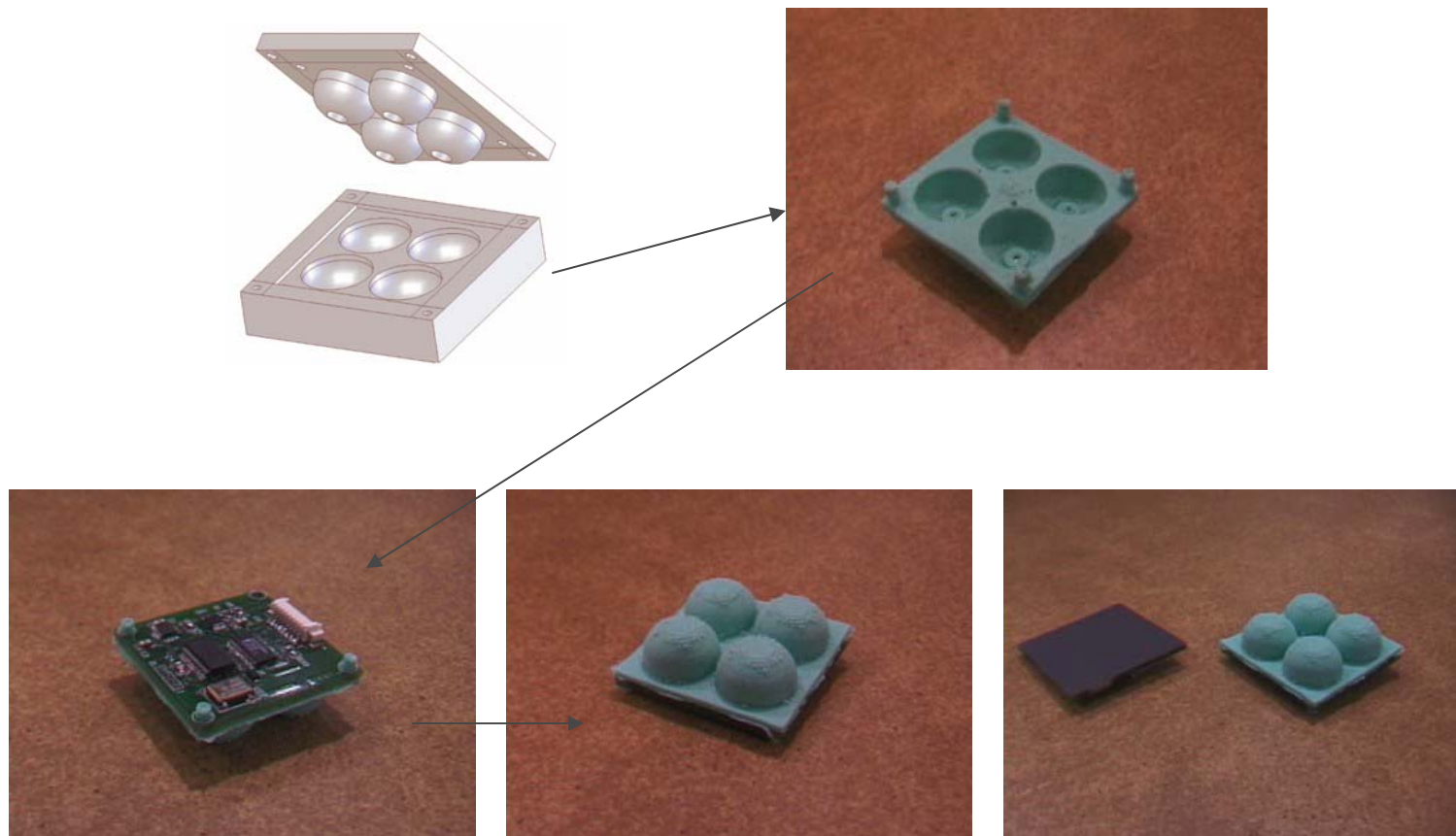


- Position of the top of the sensor gives an estimation of the force applied
- Magnetic:
 - A magnet on the dome, 4 hall effect sensors on the base
- Optical version
 - A LED and 4 photo receptors on the base

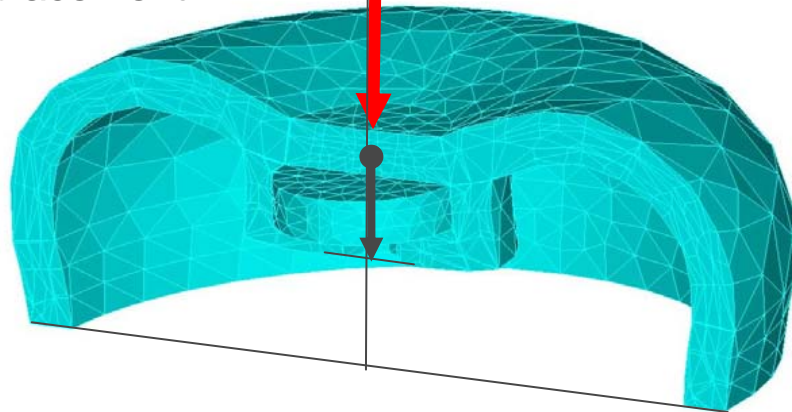
Sensor Prototyping



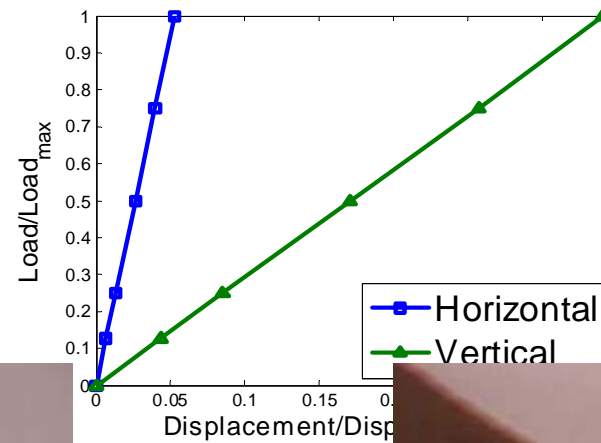
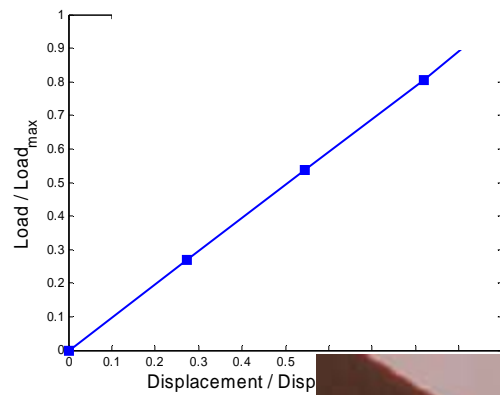
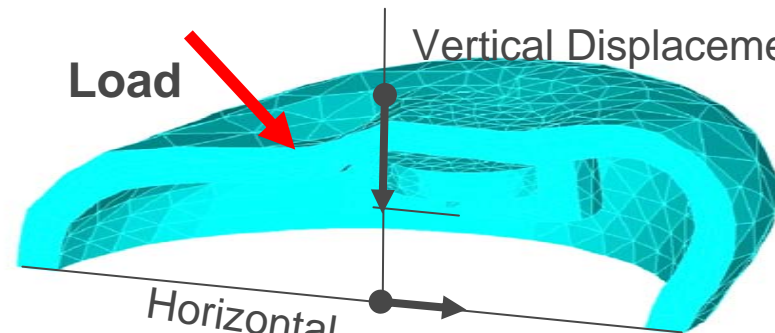
- Molding silicon rubber



Displacement Load



Load Vertical Displacement Horizontal Displacement





Movie File

Slip Detection + Correction



Micro Technology & Manipulation



- Embedded processing
 - for images, planning, control
- Tactile sensors
 - transistors in compliant materials
 - large arrays
 - sheets that can be cut and shaped
- Other tactile modalities
 - intertwined with temperature sensors
 - intertwined with sniffers
- More generally
 - not just faster, and lower power
 - embedded computation and sensing in materials